



Investigation of thermal stability of hydrogenated amorphous Si/Ge multilayers

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Thermal stability of hydrogenated amorphous Si/Ge multilayers has been investigated by Scanning Electron Microscopy (SEM), Transmission Electron Microscopy (TEM) and Small-Angle X-Ray Diffraction (SAXRD) techniques. Amorphous H-Si/Ge multilayers were prepared by RF sputtering with 1.5 and 6 ml/min H₂ flow-rate. It is shown by Elastic Recoil Detection Analysis (ERDA) that the hydrogen concentration increased by increasing the H₂ flow-rate. Annealing of the samples was carried out at 400 and 450 °C for several hours. It has been observed that samples prepared with 6 ml/min flow-rate at both annealing temperatures underwent significant structural changes: the surface of the samples was visibly roughened, gas bubbles were formed and craters were created. The decay of the periodic structure of Si and Ge layers in these types of multilayers was faster than in non-hydrogenated samples. Samples prepared with 1.5 ml/min flow-rate have similar behaviour at 450 °C, but at 400 °C the decay of the first order SAXRD peaks was slower than in case of the non-hydrogenated multilayers. Qualitatively the observed behaviour can be explained by the fast desorption of the saturated hydrogen, leading to the formation of bubbles and craters at 450 °C, as well as, at 400 °C in the sample with lower H-content, by the possible passivation of the dangling bonds resulting in a slowing down of the diffusion intermixing.

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1. Introduction

Hydrogenated amorphous silicon germanium alloys (a-Si_{1-x}Ge_x:H) are used in multi-junction solar cells in order to increase the efficiency of the cells [1,2]. One of the advantages of this material is the possibility to vary its band gap with the germanium concentration for the optimization of the exploitation of the solar spectrum. In order to improve the stability of the solar cells, a multi-junction structure is useful because each photovoltaic layer can be thinner than that of the single-junction solar cells. In case of Si/Ge amorphous multilayers the improvement of electronic properties is also accomplished by enriching them with hydrogen to passivate the dangling bonds of Si and Ge [3].

It is known that multilayers, as artificial compositionally modulated materials, are not equilibrium structures. In particular, they have high interfacial density gradients and sufficient atomic mobility even at moderate temperatures, hence changes in the composition profiles are expected to occur. Thus, not only analysis

of the light induced structural changes (i.e. Staebler–Wronski effect) [4,5], but also investigation of the thermal stability and understanding of the factors controlling the structural changes of these multilayers is required. Exploration of these mechanisms is very important for the interpretation of operation and prediction of lifetime before integrating these structures into micro and optoelectronics devices. In our previous works the thermal stability of non-hydrogenated Si/Ge multilayers [6,7] was extensively studied, but there is no information available in the literature on the effect of hydrogen addition in the intermixing of Si and Ge layers.

In this work we summarize our previous results on the structural changes [8,9], caused by the fast release of hydrogen, and present preliminary results on diffusion intermixing in amorphous Ge/Si multilayers prepared with different hydrogen content.

2. Experimental details

Hydrogenated and non-hydrogenated amorphous Si/Ge multilayers with 3 nm nominal layer thickness were deposited on (100) oriented Si substrates by the conventional radio frequency sputtering apparatus (Leybold Z 400) with base vacuum pressure of 1×10^{-6} mbar. During sputtering the chamber pressure was kept at

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2×10^{-2} mbar and the substrate was water cooled. A 1.5 kV wall potential was applied to the Si and Ge targets while argon (purity 99.999%) was used as sputtering gas. The multilayers contained a sequence of 50 Si/Ge bi-layers. The hydrogenated Si/Ge samples have been deposited by adding hydrogen in the sputtering chamber at a flow-rate of either 1.5 or 6 ml/min. Both non-hydrogenated and hydrogenated multilayers have been annealed in high purity argon (99.999%) atmosphere at 400 and 450 °C.

After preparation the hydrogen content of the multilayer films was measured with Elastic Recoil Detection Analysis (ERDA) and it was clearly observed that (a) hydrogen absorption occurred and (b) the hydrogen content was larger for higher flow-rate. In order to check the possible hydrogen loss of the sample during the measurements, Rutherford backscattering spectrometry (RBS) was also applied simultaneously. The ERDA data were normalized to the RBS data. Micro-ERDA and micro-RBS with a helium beam were performed on the Oxford-type nuclear microprobe facility at ATOMKI, Debrecen [10]. The energy of the $^4\text{He}^+$ ion beam was 1.6 MeV. Three ORTEC-type surface barrier silicon detectors (50 mm² sensitive area and 18 keV system energy resolution) were used for micro-ERDA and micro-RBS experiments simultaneously. The ERDA detector was placed at a recoil angle of 30° (IBM geometry) mounted with a 6 μm thick Mylar absorber and 1.1 mm wide vertical aperture. The tilt angle of the sample was 75°. Two detectors collected the micro-RBS data; one of them was placed at a scattering angle of 165° at Cornell geometry and the other one was set to 135° at IBM geometry. The total deposited charge was collected on the sample.

The investigations of the samples were carried out by Scanning Electron Microscopy (SEM, type Hitachi S-4300 CFE) operated in the secondary electron mode, Transmission Electron Microscopy (TEM, type JEOL 2000) and Small-Angle X-Ray Diffraction instrument equipped with Siemens Cu-anode X-Ray tube. The TEM specimens were prepared by mechanical thinning of sandwiches, containing a small piece of the sample, down to 30 μm followed by Ar ion beam thinning down to electron transparency. SEM was used for surface morphological examinations.

One of the powerful and widely used techniques for characterization of multilayers is the Small-Angle X-ray Diffraction (SAXRD) [11]. It is a non-destructive method and provides structural information on the atomic scale. The $\theta - 2\theta$ SAXRD scans were employed to investigate the diffusion processes by measuring the intensity decrease of the first order Bragg-peak which can arise from the chemical modulation of the structure [12]. Since the intensities of the low angle Bragg-peaks are strongly influenced by the sharpness of the interfaces, the decay of the intensity of the first order peak in small-angle X-ray diffraction gives information about the intermixing of the Si and Ge layers. This behaviour can even be used to measure the interdiffusion coefficients in multilayers. In fact the slope of the logarithm of the normalized intensity of the first order peak versus the annealing time is inversely proportional to the diffusion coefficient.

Two types of hydrogenated amorphous Si/Ge multilayers, prepared with 1.5 and 6 ml/min flow-rates and annealed at 400 and 450 °C for different annealing times, were investigated.

3. Results and discussion

After diffusion heat treatments (as discussed in our previous papers [8,9]) it was observed that the hydrogenated Si/Ge multilayers underwent significant structural changes. The originally flat surfaces of the samples, prepared with 6 ml/min flow-rate, were visibly roughened at both applied annealing temperatures; gas bubbles were formed and craters were created (Fig. 1a.). However the samples prepared with lower H₂ concentration (with 1.5 ml/min flow-rate

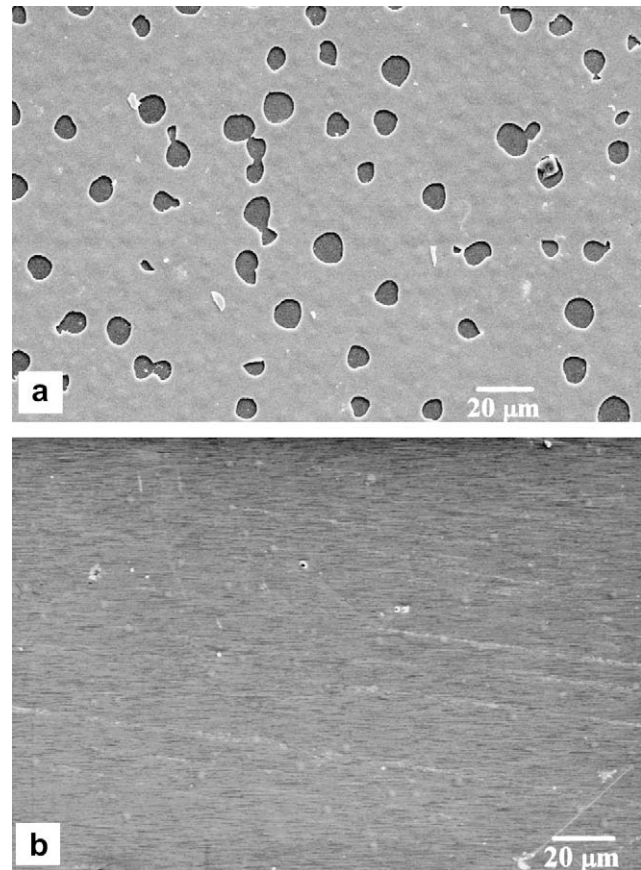


Fig. 1. Secondary electron image of the hydrogenated sample prepared with 6 ml/min hydrogen flow-rate after 8 h annealing at 450 °C (a.) and sample prepared under 1.5 ml/min hydrogen flow-rate after 10 h annealing at 400 °C (b).

of H₂) showed a similar effect only at 450 °C. During annealing at 400 °C the surface of these samples remained smooth (no craters) and only moderate bubble formation has occurred (Fig. 1b.). This indicates that the structure of the samples prepared with low hydrogen concentration was more stable at 400 °C, but at higher annealing temperature (450 °C) they can degrade similarly to samples with higher hydrogen content (prepared with 6 ml/min H₂ flow-rate).

The gas bubbles at 450 °C are formed due to the enhanced precipitation of the supersaturated hydrogen. The intensive growth of the bubbles can blow up the multilayered film locally. On the other hand, the TEM pictures (Fig. 2) and small-angle X-ray measurements show that despite the formation of craters, the multilayer structure is preserved. This offers an opportunity to perform a diffusion experiment which is able to indicate classical intermixing between amorphous Ge and Si still containing some hydrogen. Thus, after each annealing the small-angle X-ray spectrum has been recorded and the logarithm of the normalized intensity of the first order Bragg-peak has been plotted as a function of an annealing time. Fig. 3 shows these experimental results. The slope of the curves can show that diffusion took place between the Si and Ge layers. The non-linearity of the time dependence of $\ln I/I_0$ indicates that the diffusion coefficient strongly depends on the composition and/or significant stresses of diffusion origin were formed during the heat treatments [7]. Nevertheless some qualitative conclusions can be obtained from the comparison of the above decay curves. First, both hydrogenated samples show a fast structural degradation at 450 °C and, according to the SEM pictures, beside the diffusion intermixing, the morphological changes (bubbles, craters) can also play a significant role. The same

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